

<b>Notice of References Cited</b>	Application/Control No. 10/724,793	Applicant(s)/Patent Under Reexamination VOUTE ET AL.	
	Examiner Chen-Wen Jiang	Art Unit 3744	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,586,097 A	06-1971	Bender et al.	392/444
	B	US-6,605,213 B1	08-2003	Ammann et al.	210/222
	C	US-5,616,301 A	04-1997	Moser et al.	422/104
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
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	S					
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**NON-PATENT DOCUMENTS**

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